ÍTED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Chang, Christopher C. et al.

Application No.: 09/749,917

Filed: December 29, 2000

Low Contamination Plasma

Chamber Components and Methods

for Making the Same

MAIL STOP: OFFICIAL **DRAFTSMAN**

Group Art Unit: 1773

Examiner: NIKOLAS J. UHLIR

Confirmation No.: 6832

SUBMISSION OF FORMAL DRAWINGS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed please find 4 replacement sheet(s) of formal drawings for review by the U.S. Patent and Trademark Office. Should the enclosed drawing(s) require changes, it is respectfully requested that the U.S. Patent and Trademark Office notify the undersigned of same.

Respectfully submitted,

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Date: July 23, 2004

By:

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